

20th INTERNATIONAL

VACUUM CONGRESS

IVC-20

AUGUST 21-26, 2016

BUSAN, KOREA



SPONSORSHIP & EXHIBITION PROSPECTUS



ICSS-16

ITC 2016

ISPB 2016























Dear Colleagues and Friends,

On behalf of the Organizing Committee, it is our great honor and pleasure to invite you to the 20th International Vacuum Congress (IVC-20), which will be held in Busan, Korea from August 21 to 26, 2016.

WELCOME MESSAGE The Korean Vacuum Society (KVS) will have the privilege of hosting IVC in Korea, and plans to go to great lengths to ensure the Congress surpasses all expectations and provides a meaningful educational, social and cultural experience for all participants.

In the tradition of the IVC series, IVC-20 will integrate the 16th International Conference on Solid Surfaces (ICSS-16), International Conference on Nanoscience and Technology 2016 (ICN+T 2016), and 8th Vacuum and Surface Sciences Conference of Asia and Australia (VASSCAA-8). In addition, the International Symposium of Plasma Biosciences 2016 (ISPB 2016), 25th Anniversary KVS Symposium (25th KVS), and Industrial Topical Conference 2016 (ITC 2016) will also be incorporated. ITC 2016 has been specially included to emphasize the balance between academia and industry.

IVC-20 will not only provide a comprehensive overview of the most recent developments in the field of vacuum science and the latest technologies and applications, but also feature a unique and extensive technical exhibition.

With her natural beauty and diverse tour attractions, the city of Busan will surely be the center of many unforgettable moments.

We look forward to welcoming you in Busan, Korea!

Sincerely yours,

Prof. Hee Jae Kang

Cangue

General Chair, 20th International Vacuum Congress President, Korean Vacuum Society Dr. Choong-Ryul Paik

Chair, International Industrial Committee of IVC-20 Chief Director, Korea Vacuum-technology Research Association

THE IVC SERIES IS THE WORLD'S LARGEST EVENT IN THE VACUUM FIELD.

In IVC-20, multiple conferences are merged into a joint congress. About 2,000 participants from around the world are expected to attend the congress, including academics and industrial researchers.

IVC-20

20th International Vacuum Congress August 21-26, 2016 BEXCO, Busan, Korea

IVC-20 **OVERVIEW**

20 will integrate ICSS-16, ICN+T 2016, and VASSCAA-8. In addition, ISPB 2016, 25th KVS, and ITC 2016 will also be incorporated. ITC 2016 has been specially included to emphasize the balance between academia and industry.

In the tradition of the IVC series, IVC-

DATE

TITLE

August 21-26, 2016

VENUE

BEXCO, Busan, Korea

ORGANIZED BY

International Union for Vacuum Science, Technique and Applications (IUVSTA) Korean Vacuum Society (KVS)

· IVC-20 (20th International Vacuum Congress)

· 25th KVS (25th Anniversary KVS Symposium)

· ITC 2016 (Industrial Topical Conference 2016)

· ICSS-16 (16th International Conference on Solid Surfaces)

· ISPB 2016 (International Symposium of Plasma Biosciences 2016)

· ICN+T 2016 (International Conference on Nanoscience and Technology 2016) · VASSCAA-8 (8th Vacuum and Surface Sciences Conference of Asia and Australia)

SUPPORTED BY

Ministry of Science, ICT and Future Planning (MSIP) Ministry of Trade, Industry and Energy (MOTIE) KOrea Vacuum-technology Research Association (KOVRA) Busan Metropolitan City The Korean Federation of Science and Technology Societies (KOSFT) Korea Tourism Organization Busan Tourism Organization

OFFICIAL LANGUAGE

English

WEBSITE

www.ivc20.com

SCALE

Participants: 2,000 from 60 countries (Overseas 1,000, Domestic 1,000)

Number of Booths: 120

TOPICS

IVC-20 will include:

- + Applied Surface Science
- + Biointerfaces
- + Electronic Materials and Processing
- + Nanometer Structures
- + Plasma Science and Technique
- + Surface Engineering
- + Surface Science
- + Thin Films
- + Vacuum Science and Technology
- + 2D Materials and Devices
- + Advanced Semiconductor and Display Devices
- + Alternative Energy; Fuel Cells, Solar Cells, Battery, Capacitors, Catalysts
- + Plasma Bioscience and Medicine

PLENARY SPEAKERS

- + Joanna Aizenberg (USA) Director, Kavli Institute, Harvard University
- + Kinam Kim (Korea)

President, Semiconductor Business Samsung Electronics Co. Ltd.

+ Erwin Neher (Germany)

Nobel Laureate in Physiology or Medicine Director, Max Planck Institute for Biophysical Chemistry

+ Hideo Ohno (Japan) Professor, Tohoku University

+ Qi-Kun Xue (China) Vice President, Tsinghua University

IVC-20

20th International Vacuum Congress August 21-26, 2016 BEXCO, Busan, Korea

WHY IVC-20?

5 REASONS TO PARTICIPATE IN IVC-20!

1

The largest and most prestigious event in the field

2

Experience the Korean market with the latest innovations

3

Excellent platform to extend your marketing reach worldwide

4

Strengthen the credibility of your brand and products

5

Build relationships with key decision makers



Nearly 2,000 physicists, chemists, materials scientists, engineers and technologists who are active in basic and applied research, development, manufacturing, sales and education will gather together in one location for this premier event. Participating in the IVC-20 Exhibition will provide your company with a unique opportunity to promote your products and services to key companies and organizations. Meet face-to-face with your target audience to develop new relationships and network with your colleagues, turning your investment into valuable business.

IVC-18

IVC-19

IVC-20

China 2010

France 2013

Korea 2016

BECOME OUR SPONSOR!

Maximize the effectiveness of your promotion before and during the event by featuring your company's brand and products! Various sponsorship programs have been prepared to enhance your brand awareness.

IVC – 20 20th International Vacuum Congress August 21-26, 2016 BEXCO, Busan, Korea

SPONSORSHIP OPPORTUNITIES

SPONSORSHIP PACKAGE

Sponsorship Level Amount	Diamond USD 30,000	Platinum USD 10,000	Gold USD 5,000	Silver USD 3,000
Pre-congress advertising				
Logo on congress announcements	0	0	0	0
Logo on website main page	0	0	0	_
Banner link in e-newsletter	0	0	0	_
Company acknowledgement in e-newsletter	0	-	_	-
Congress advertising				
Final program - inside page	1 page	1 page	½ page	½ page
Main stage - logo printing	0	0	0	_
Logo on screen saver in session rooms	0	0	0	_
Priority in industrial symposia application	First	Second	_	_
Advertisement insert in congress bag	0	0	_	_
Logo on the name badge lanyards	0	-	_	-
Exhibition Space				
Priority in the selection of booth location	First	Second	Third	Fourth
Free booth (3m X 2m)	6 booths	4 booths	2 booths	1 booth
Additional exhibition space discount	25%	20%	15%	10%
Registration				
Full registration	5	3	2	1

OTHER SPONSORSHIP ITEMS

Sponsorship Item	Price
Final Program – 1 inside page	USD 1,500
Others	Negotiable

 $[\]mbox{\ensuremath{^{\ast}}}$ Donations and other suggestions will be possible.



20th International Vacuum Congress August 21-26, 2016 BEXCO, Busan, Korea

EXHIBITION INFORMATION

JOIN THE EXHIBITION!

An extensive technical exhibition will take place alongside the congress. The standard booth is $2m \times 3m$, and can be purchased in multiples of 6 square meters. The exhibition will be open to non-participant visitors, thus maximizing interaction with potential buyers.

Place	2A Hall, 1F Exhibition Center, BEXCO, Busan, Korea	
Period	August 23 (Tue) – 25(Thu), 2016	
Hours of Operation	08:00-18:00	

EXHIBITION FEES

Booth Type	Description	Price
Shell Scheme Booth	 Signs with company name and booth number One information desk and one chair Spotlight, fluorescent light Floor (pytex) Electricity 1kW 1 socket 	USD 2,000 / booth
Space Only	- Electricity 1kW - 1 socket	USD 2,000 / booth



APPLICATION PROCEDURE

- 1. Please fill out the sponsorship / exhibition application form and email it to the IVC-20 Secretariat along with a copy of your business license.
- 2. Submit a deposit of 30% of the total amount / full payment to confirm your application.
- 3. After completing payment, please send the receipt to the secretariat for confirmation.
 - · All transaction fees are borne by the applicant.
 - · All benefits will go into effect after receiving the applications. Some benefits will not be available if you apply late due to the printing schedule.
 - · Full payment of the sponsorship and exhibition must be made by the schedule determined by the organizing committee.

IVC-20 20th International Vacuum Congress August 21-26, 2016 BEXCO, Busan, Korea

HOW TO APPLY?

BANK INFORMATION

Payments should be transferred to the following bank account. All bank charges are the responsibility of the applicant.

- · Bank Name: Citibank Korea Inc.
- · Branch Name: Teheran-ro Branch
- · Account Number: 163-02293-431-01
- · Account Holder Name: The Korean Vacuum Society
- · Swift Code: CITIKRSXXXX
- · Bank Address: Haesung 2 Bldg. 942-10 Daechi-dong, Gangnam-gu, Seoul 135-725, Korea

IMPORTANT DATES

- · May 31, 2016: Final payment due for sponsors
- · June 30, 2016: Final payment due for exhibitors

CANCELLATION POLICY

All cancellations must be notified in writing to the IVC-20 Secretariat.

- · The initial deposit of 30% of the total amount will not be refunded.
- \cdot 50% of the total fee is refundable for cancellations made before May 31, 2016.
- \cdot After May 31, 2016, there will be no refunds.

INQUIRIES

IVC-20 Secretariat: People-X, Inc.

- · Phone: +82-2-557-8422
- · Fax: +82-2-566-6087
- · E-mail: contact@ivc20.com
- · Website: www.ivc20.com
- · Address: 1F Haeoreum Bldg., 16, Yeoksam-ro 17-gil, Gangnam-gu, Seoul 06246, Korea

IVC-20 SPONSORSHIP APPLICATION FORM

Please send the completed form to the IVC-20 Secretariat by email to contact@ivc20.com.

1. COMPANY INFORM	MATION			
Company Name				
Business Field		Exhibition Item	1	
Address				
City		Zip Code		
Country		Phone		
Fax		Website		
2. CONTACT INFORM	MATION			
Name		Position		
Department	Phone			
E-mail		Mobile		
3. SPONSORSHIP LEV	VEL			
Package Name	Diamond	Platinum	Gold	Silver
Price	□ USD 30,000	□ USD 10,000	☐ USD 5,000	□ USD 3,000
4. ADDITIONAL SPO				
Category	Description		Prid	
	☐ Diamond Sponsor		booth(s) X USD 1,500	
Additional Exhibition Space	☐ Platinum Sponsor		booth(s) X USD 1,600	
$(3m \times 2m = 6m^2)$	☐ Gold Sponsor		booth(s) X USD 1,700	
	☐ Silver Sponsor		booth(s) X USD 1,800	
Congress Advertising	☐ Final Program - InsidePage	age Page(s) X USD 1,500		(USD 1,500
	Other:		Negot	iable
5. PAYMENT INFORM	IATION			
Total Amount	USD			
Deposit (30%)	USD			
Remarks	* 30% of non-refundable de	eposit is to be settled. * Balan	nce Due Date: May 31, 2016	
Bank Name	Citibank Korea Inc.			
Branch Name	Teheran-ro Branch			
Account Number	163-02293-431-01			
Account Holder	The Korean Vacuum Society			
	CITIKRSXXXX			
Swift Code	CHIKRSXXXX			

Date (MM/DD/YY): _____

_____ Signature : ___

IVC-20 EXHIBITION APPLICATION FORM

Please send the completed form to the IVC-20 Secretariat by email to contact@ivc20.com.

1. COMPANY INFO	DRMATION		
Company Name			
Business Field	Exhibition Item	1	
Address			
City	Zip Code		
Country	Phone		
Fax	Website		
2. CONTACT INFO	RMATION		
Name	Position		
Department	Phone		
E-mail	Mobile		
3. BOOTH TYPE Package Name	Description	Price	
Exhibition Booth	☐ Shell Scheme Booth	hooth(s) VIICD 2 000	
$(3m \times 2m = 6m^2)$	☐ Space Only	booth(s) X USD 2,000	
4. PAYMENT INFO	RMATION		
Total Amount	USD		
Deposit (30%)	USD		
Remarks	* 30% of non-refundable deposit is to be settled. * Balance Due Date: June 30, 2016		
Bank Name	Citibank Korea Inc.		
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Account Number	163-02293-431-01		
Account Holder	The Korean Vacuum Society		
Swift Code	CITIKRSXXXX		
	Haesung 2 Bldg. 942-10 Daechi-dong, Gangnam-gu, Seoul 135-725, Korea		

Date (MM/DD/YY): _____ Signature : _____



